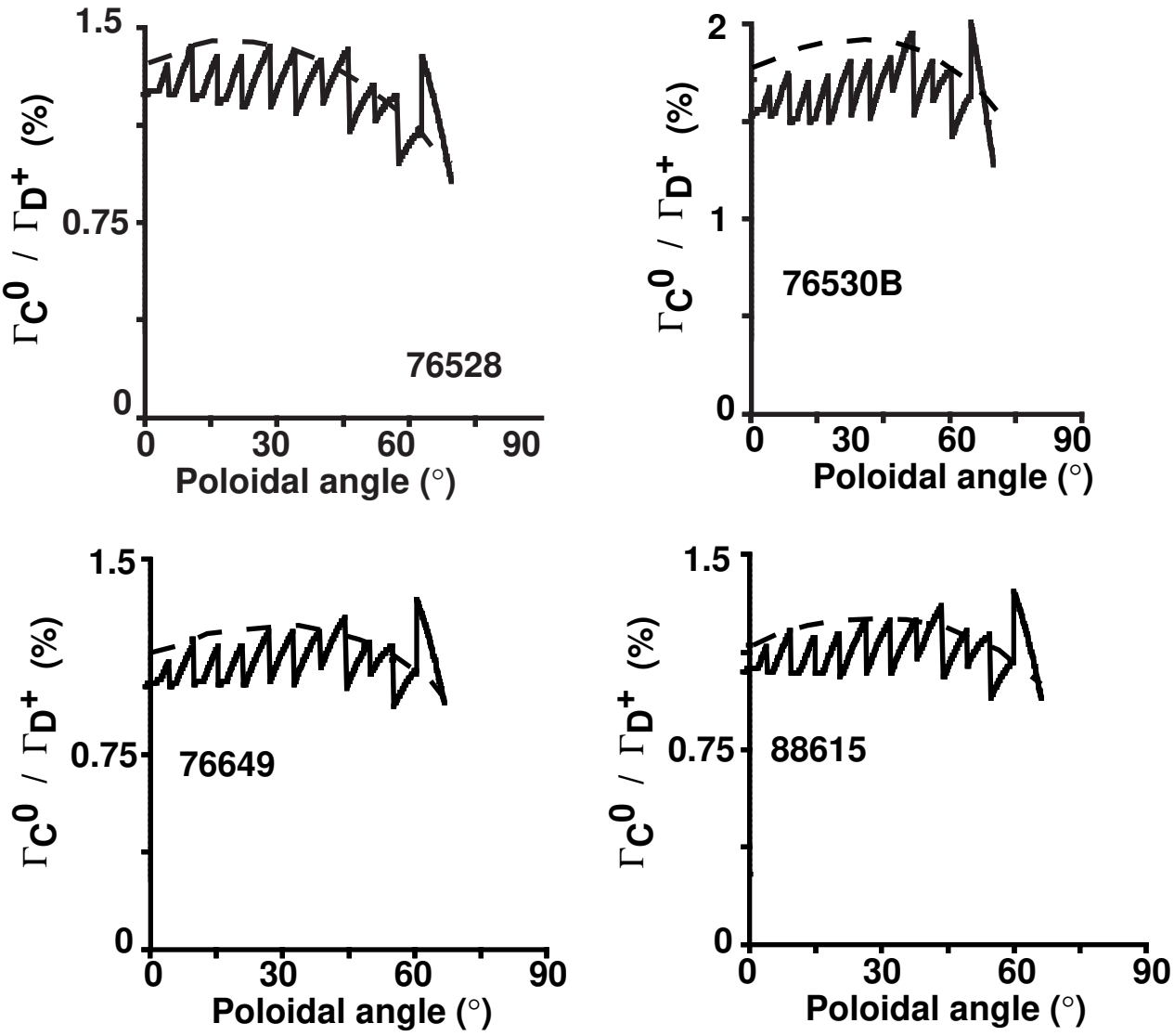

FIG. 2
Calculated local effective sputtering yield distributions
(emitted impurity flux / incident D^+ flux)
for the four cases of Table 2, with $\Gamma_\perp (0) / \Gamma_{//}(0) = 0.4$